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80 Data Sheet

CONFIRMATION NO. 1952

SERIAL NUMBER 09/964,648	FILING DATE 09/28/2001 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. 862.C2397	
APPLICANTS Keiji Yoshimura, Tochigi, JAPAN; ** CONTINUING DATA PONG R ** FOREIGN APPLICATIONS JAPAN 2000/302162 10/02/2000 JAPAN 2001/089762 03/27/2001 IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 11/14/2001					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Not after Allowance Verified and Acknowledged <input checked="" type="checkbox"/>		STATE OR COUNTRY JAPAN	SHEETS DRAWING 15	TOTAL CLAIMS 27	INDEPENDENT CLAIMS 48
ADDRESS 05514					
TITLE Exposure apparatus, semiconductor device manufacturing method, exposure apparatus maintenance method and semiconductor manufacturing factory					
FILING FEE RECEIVED 1396	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		

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